

Notice of References Cited	Application/Control No. 10/791,197	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Anastasia Midkiff	Art Unit 2882	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0131884	07-2004	Park et al.	428/690
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP 82102225 A2	11-1982	EPO	Aboelfotoh, Mohamed	H01J 61/62
	O	JP 11-339665	12-1999	Japan	Keiji, Watabe, et al.	H01J 11/02
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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